



Attorney Docket No. 0756-7219

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Tatsuya ARAO et al.

Serial No. 10/706,978

Filed: November 14, 2003

For: METHOD FOR FABRICATING

SEMICONDUCTOR FILM AND

SEMICONDUCTOR DEVICE AND

LASER PROCESSING APPARATUS

) Group Art Unit: 2812

) Examiner: Richard A. Booth

) CERTIFICATE OF MAILING

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Richard A. Booth

**AMENDMENT**

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated November 14, 2005, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.